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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yamazaki et al.
Appl. No. : Unknown (U.S. National Phase of
PCT/JP2004/013633)
Filed : Herewith
For : POSITIVE RESIST
COMPOSITION AND METHOD
OF FORMING RESIST PATTERN
Examiner : Unassigned
Group Art Unit : Unknown

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all
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Commissioner for Patents, P.O. Box 1450,
Alexandria, VA 22313-1450, on

January 30, 2006

(Date)

Neil S. Bartfield, Ph.D., Reg. No. 39,901

PRELIMINARY AMENDMENT

Mail Stop PCT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Prior to examination of the above-referenced application, please enter the following
amendments.

Amendments to the Specification begin on page 2 of this paper.

Remarks begin on page 4 of this paper.